

Paweł, Knapkiewicz

List of Publications by Year in descending order

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#	ARTICLE	IF	CITATIONS
1	Ultra-low temperature anodic bonding of silicon and borosilicate glass. <i>Semiconductor Science and Technology</i> , 2019, 34, 035005.	2.0	8
2	Technological Assessment of MEMS Alkali Vapor Cells for Atomic References. <i>Micromachines</i> , 2019, 10, 25.	2.9	23
3	Alkali Vapor MEMS Cells Technology toward High-Vacuum Self-Pumping MEMS Cell for Atomic Spectroscopy. <i>Micromachines</i> , 2018, 9, 405.	2.9	11
4	High-dose radiation sensor with wireless optical detection. <i>Measurement Science and Technology</i> , 2017, 28, 054009.	2.6	3
5	Anodic Bonding of Glass-to-Glass through Magnetron Spattered Nanometric Silicon Layer. <i>Procedia Engineering</i> , 2011, 25, 1629-1632.	1.2	8
6	First-order cancellation of the Cs clock frequency temperature-dependence in Ne-Ar buffer gas mixture. <i>Optics Express</i> , 2011, 19, 3106.	3.4	12
7	MEMS caesium vapour cell for european micro-atomic-clock. <i>Procedia Engineering</i> , 2010, 5, 721-724.	1.2	21
8	Microsensors for Microreaction and Lab-on-a-Chip Applications. , 0, , .		5